



**THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Jia-Chong HO et al. Confirmation No: 2765  
Appl. No. : 10/730,073  
Filed : December 9, 2003  
Title : COMPOUND SEMICONDUCTOR MATERIAL AND METHOD  
FOR FORMING AN ACTIVE LAYER OF A THIN FILM  
TRANSISTOR DEVICE

TC/A.U. : 2822  
Examiner : T. Y. Tran

Docket No.: : HOJ13001/REF  
Customer No: : 23364

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Official Action of June 30, 2005, in connection with the above-identified application. The period for reply has been extended to expire on November 30, 2005 by the filing herewith of a Petition for a Two Month Extension of time and payment of the required fee.

Please amend the application as follows:

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.